

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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First Named Inventor	Ono
Art Unit	1644
Examiner Name	Not yet assigned

U.S. PATENT DOCUMENTS

Copies of U.S. Patent documents do not need to be provided, unless requested by the Patent and Trademark Office. For patents, provide the patent number and the issue date. For published U.S. applications, provide the publication number and the publication date. For unpublished pending patent applications, provide the application number and the filing date.

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
/LB/		2004/058393 A1	3/25/2004	Fukishima <i>et al.</i>
/LB/		2006/0275301 A1	12/7/2006	Ozaki <i>et al.</i>

FOREIGN PATENT DOCUMENTS

Examiner's Initials*	Cite No. (optional)	Country	Number	Publication Date	Name of Applicant or Patentee
/LB/		WIPO	WO 02/094880 A1	11/28/2002	Kirin Beer Kabushiki Kaisha
/LB/		WIPO	WO 02/097033 A2	12/5/2002	Human Genome Sciences, Inc.

OTHER DOCUMENTS

Examiner's Initials*	Cite No. (optional)	
/LB/		Chuntharapai <i>et al.</i> , "Isotype-Dependent Inhibition of Tumor Growth In Vivo by Monoclonal Antibodies to Death Receptor 4," <i>J. Immunol.</i> 166:4891-4898 (2001).
↓		Cochlovius <i>et al.</i> , "Cure of Burkitt's Lymphoma in Severe Combined Immunodeficiency Mice by T Cells, Tetravalent CD3 x CD19 Tandem Diabody, and CD28 Costimulation," <i>Cancer Res.</i> 60:4336-4341 (2000).
↓		Griffith <i>et al.</i> , "Functional Analysis of TRAIL Receptors Using Monoclonal Antibodies," <i>J. Immunol.</i> 162:2597-2605 (1999).
↓		Hudson <i>et al.</i> , "High Avidity scFv Multimers; Diabodies and Triabodies," <i>J. Immunol. Methods</i> 231:177-189 (1999).

EXAMINER
SIGNATURE:

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CONSIDERED: 08/27/2009

* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.